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***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

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In re application of: ARONOWITZ et al.

Attorney Docket No.: 02-5804/LSI1P212

Application No.: 10/697,506

Examiner: Bret P. Chen

Filed: November 29, 2003

Group: 1762

Title: VAPORIZATION AND HANDLING OF  
METALS FOR USED IN SEMICONDUCTOR  
PROCESSING

Confirmation No.: 8055

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I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on July 13, 2007.

Signed:                     /swx/                    

Susan W. Xu

**AMENDMENT D**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Examiner:

This Amendment is in response to the Office Action dated May 31, 2007. It is respectfully requested that the above-referenced patent application be reconsidered in light of the remarks made herein below. The applicants kindly request that the Examiner allow the above-entitled application as set forth below:

**Amendments to the Claims** are reflected in the listing of claims beginning on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.